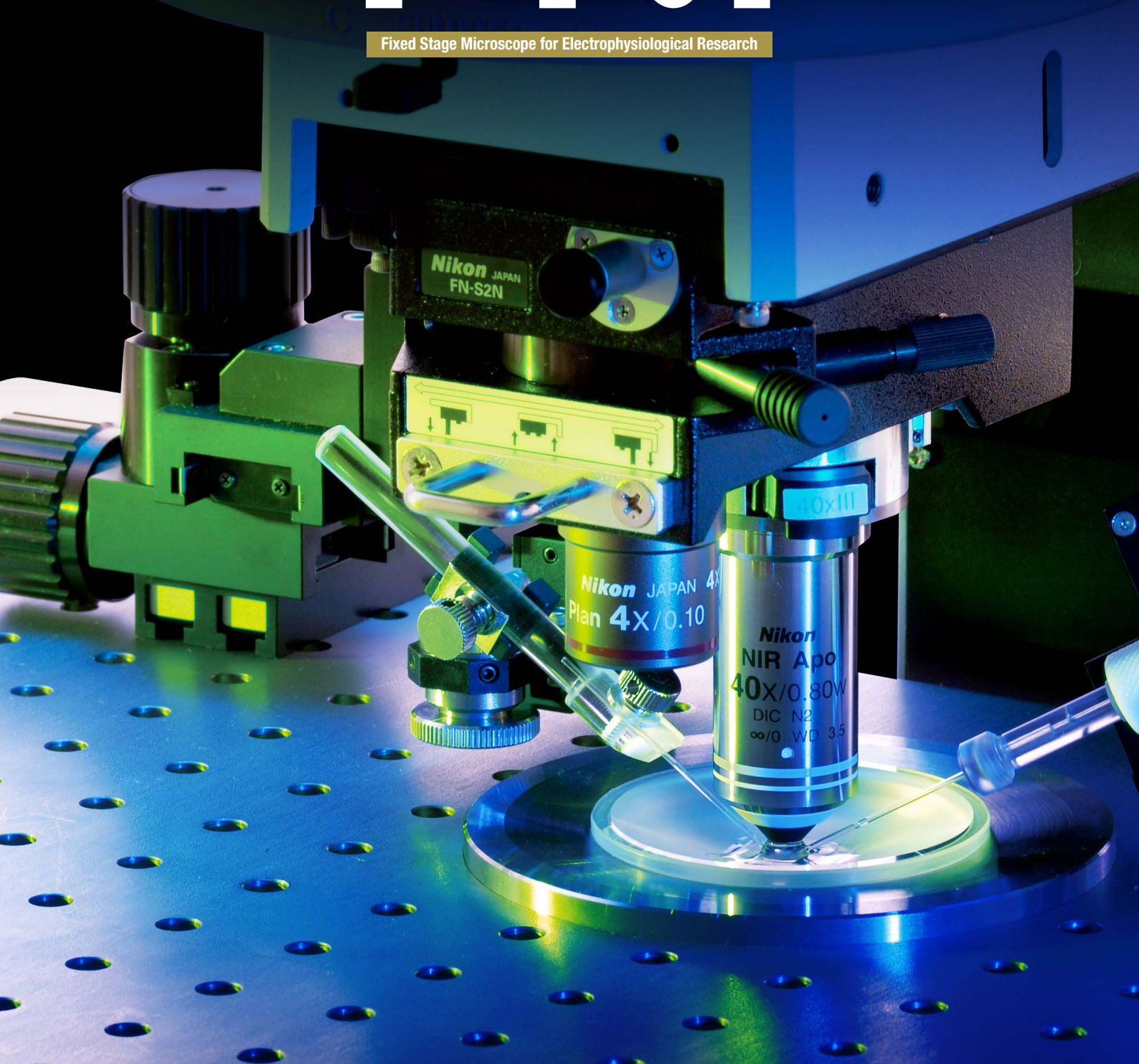




Fixed Stage Microscope for Electrophysiological Research
ECLIPSE FN1

ECLIPSE FN1

Fixed Stage Microscope for Electrophysiological Research



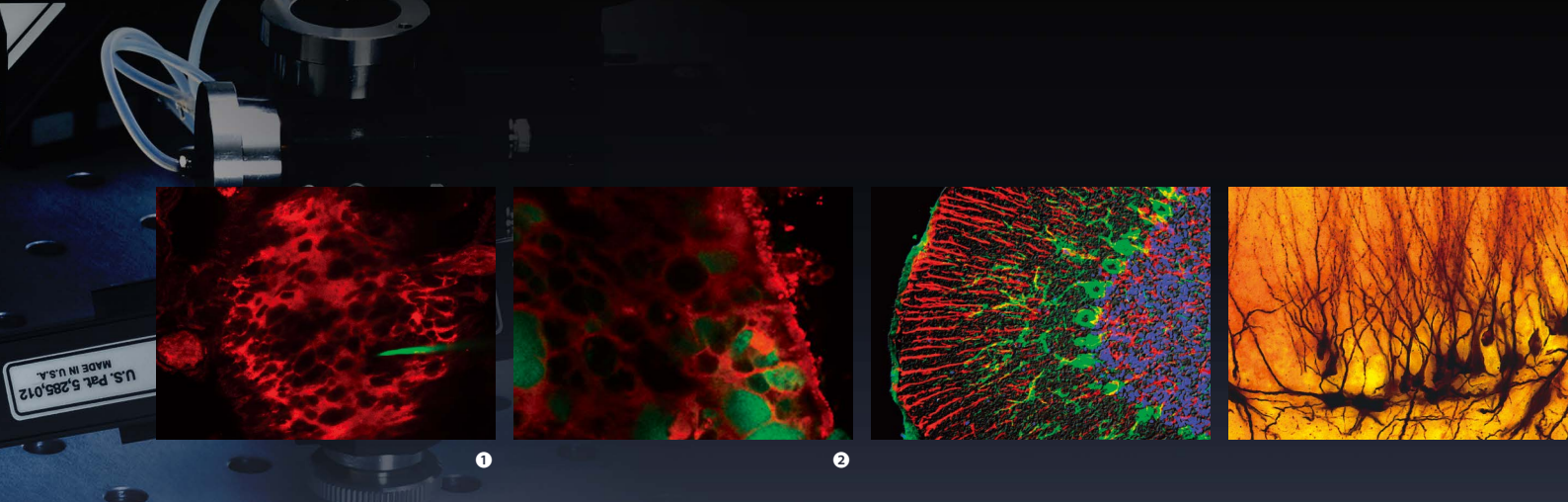
ECLIPSE FN1

Fixed Stage Microscope for Electrophysiological Research

State-of-the-art Research Microscope
Optimized for Observation and
Analysis of *in Vivo*/*in Vitro* Nervous Activity



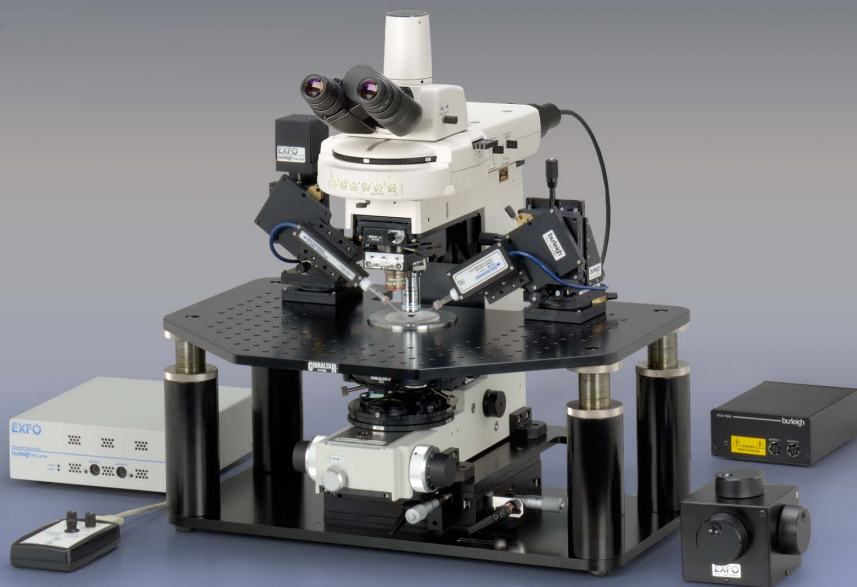
Configuration with Narishige stage



The Eclipse FN1 is a special purpose upright microscope developed to meet the rigorous demands of electrophysiological research.

Never before has an electrophysiological microscope enabled visualization of minute details deep within a specimen with such clarity and contrast. The FN1 has a completely redesigned optical system that includes the world's first water dipping objective with depth-induced aberration correction.

Moreover, in combination with the new multiphoton confocal microscope system A1R MP+, high sensitivity deep in-vivo confocal images can be acquired at high speed.



Configuration with EXFO stage



Configuration with Nikon stage

Variable magnification double port

16x objective

New Objective Lenses Allow Imaging of Deeper Areas with Ultimate Clarity

The true one-lens solution: LWD 16x objective

By using a variable magnification double port (optional), the 16x objective allows you to capture images from a low magnification wide field at 5.6x to a high magnification high resolution at 64x with the rear port CCD camera*¹ with the same lens.

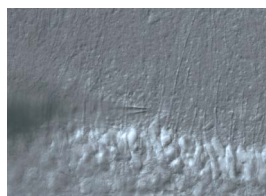
A wide viewfield of up to 2.0mm can be achieved at 0.35x intermediate magnification, enabling the observation of whole specimens and easy electrode placement.

Variable magnification double port varies magnification between three levels (0.35x/2x/4x or 0.35x/1x/4x).

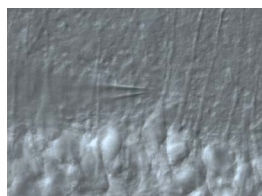
*Magnification of the front port is not variable.



5.6x (magnification 0.35x)



32x (magnification 2x)



64x (magnification 4x)

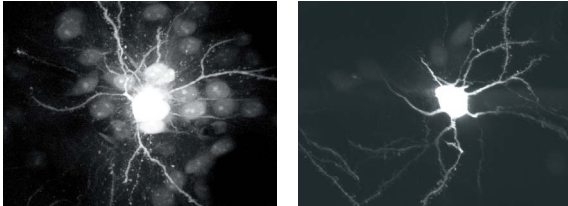
Images courtesy of: Dr. Hiroyoshi Miyakawa, Dr. Shigeo Watanabe, Tokyo University of Pharmacy and Life Science



As the 16x objective has a wide 45° manipulator approach angle and 3.0mm long working distance.

The world's first water dipping objective with depth-induced aberration correction

The Plan 100xW objective (NA 1.1, W.D. 2.5mm) is the world's first water dipping lens with a correction ring. This ring corrects spherical aberration induced by imaging deep in tissue or by working at physiological temperatures — providing outstanding Z-axis resolution in IR-DIC imaging, as well as a tight point spread function for confocal applications. With excellent IR transmission, this lens is a terrific choice for Multi-Photon imaging.



Images courtesy of: Hiroyuki Hakoziaki MS, University of California, San Diego

New objective series — ideal for IR-DIC imaging

Axial chromatic aberration in the visible to near-infrared region (up to 850nm) has been corrected in CFI APO 40xW NIR and 60xW NIR objectives. This enables the user to observe/document minute structures of a thick specimen with ample resolution. In addition, transmittance of every objective is exceptionally high, even in the IR region, thanks to wide-range spectrum anti-reflection coatings.



Easy insertion of microelectrode

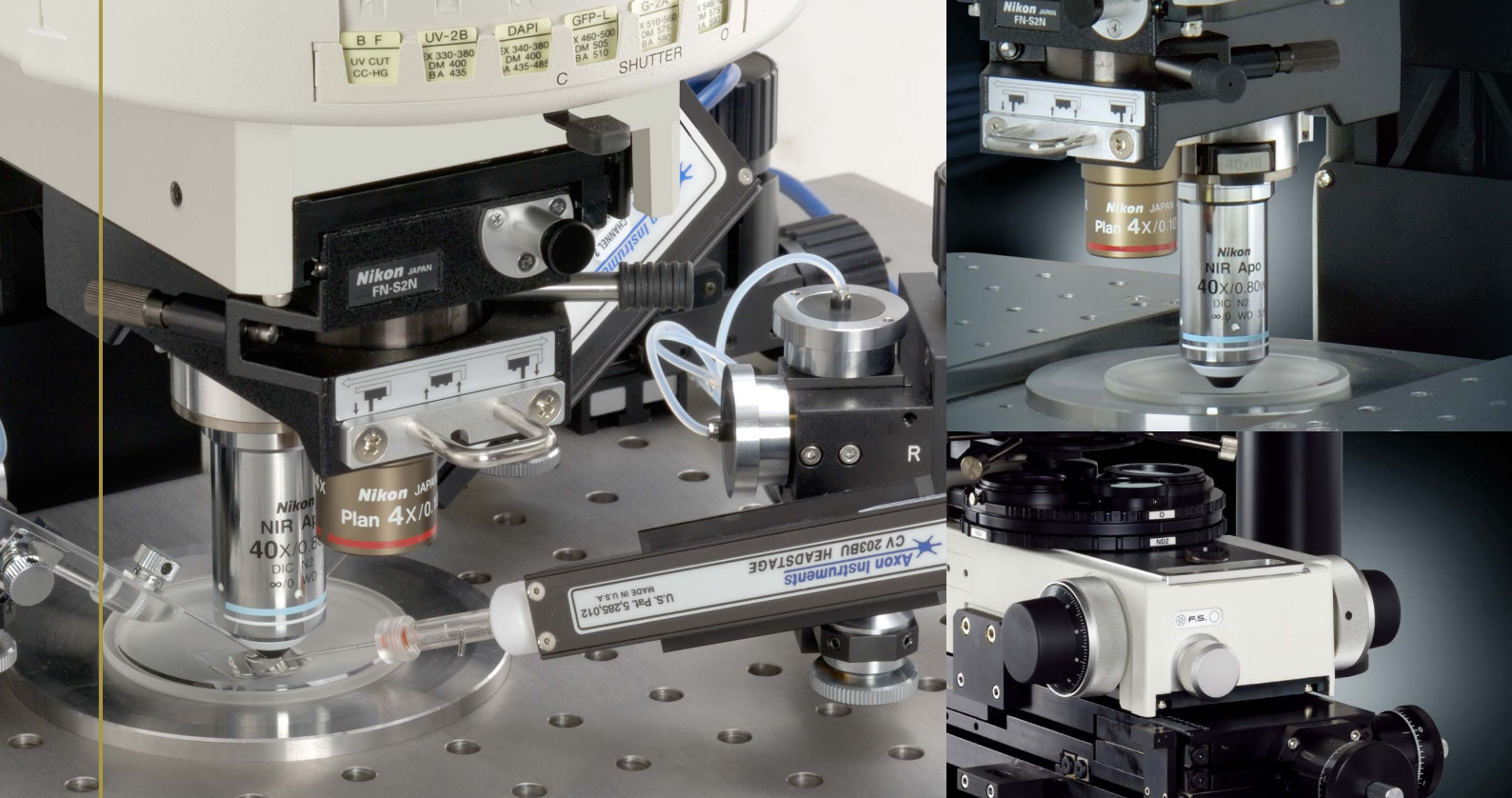
The objectives boast a long W.D. of 2.5-3.5mm (2.5mm even at 60x or 100x), taking advantage of the 60mm parfocal distance of the CFI60 optics. Since there is ample space above the specimen, microelectrodes can be easily inserted. The diameters of the objectives are 17% slimmer than previous lenses, and provide broad approach angles up to 45°, facilitating dramatically enhanced access of microelectrodes to the specimen.



45° approach angle, long working distance



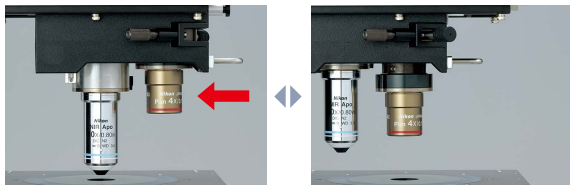
Water dipping objective CFI Plan 100xW
Water dipping objective CFI75 LWD 16xW



Streamlined Electrophysiological Experiments and Broad Work Space

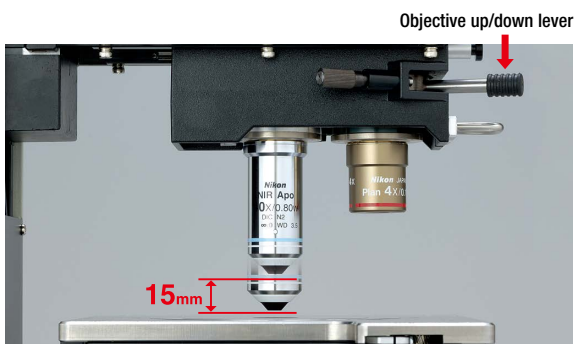
■ Smoother objectives changeover

The FN1 comes with a 2-position sliding nosepiece. A high magnification objective can be mounted on either the front or back position.



Front/back sliding objective changeover

The objectives can be raised by the lever to prevent collision with the manipulator or the chamber when they are being changed. The retraction distance is 15mm, so even a thick glass dish is protected.



Objective retraction mechanism

■ Parfocal distance correction and centering mechanism

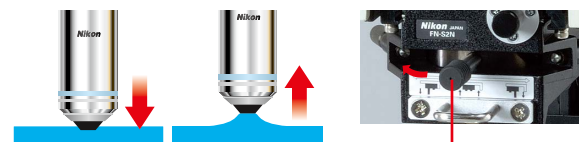
The parfocal distance of both the front and rear objectives can be finely tuned to achieve perfect parfocality. The front objective has a centering mechanism, which ensures perfect parcentricity, making it simple to find your cell when switching to a higher magnification.

Parfocal distance correction knob



■ Safe, accurate dipping operation

After the objective has been lowered, it can be further lowered by approximately 1mm by depressing the lens up/down lever to gently dip the lens top into the bath solution. This eliminates the risk of specimen disturbance due to the lowering of the objective deep into the solution.

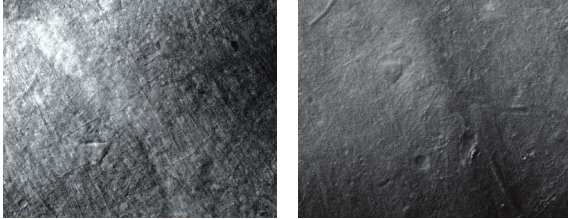


Simple lever operation ensures safe dipping

Objective up/down lever

Simple wavelength/illumination switchover

Alternating wavelength from visible to IR (infrared), or illumination technique from DIC and Oblique Light is carried out simply by rotating the wavelength selection and illumination selection turrets. Oblique illumination provides high contrast with deeper shadows by providing incident illumination at shallow angles.



Observed under oblique illumination

Observed under IR-DIC illumination

Images courtesy of: Dr. Hiroyoshi Miyakawa, Dr. Shigeo Watanabe, Tokyo University of Pharmacy and Life Science



Illumination selection turret

The user can choose between DIC illumination and oblique illumination. The oblique illumination direction can be freely adjusted by rotating the incident illumination 360°, making it easy to identify the microelectrode position.

Wavelength selection turret

The user can choose from IR-DIC, visible DIC and brightfield. Deeper tissue penetration into a specimen can be clearly visualized by choosing infrared wavelengths between 850 and 950nm.

Waterproof LWD condenser with increased flexibility

Nikon has developed a new LWD condenser that can easily be switched between brightfield, DIC, and Oblique Light illumination techniques by simply rotating the turret. The new condenser has a long working distance, providing a wide space between it and the specimen. In addition, the condenser surface is waterproof and comes with a solution reservoir to catch spills. The condenser can be easily removed — even if you are using a fixed stage — and it can be cleaned without causing vibration to the manipulator.



The condenser and polarizer turret can be simply and quickly removed.

Streamlined operation

The focus knob and field diaphragm adjustment are located on the front part of the base to enable efficient focusing. Moreover, there are no cumbersome belts outside the base. The coarse/fine focus knob is located on both the left and right sides, so it can be operated with either hand. In addition, the optional remote handle enables ON/OFF and light intensity adjustment of the fiber illumination from outside the cage.



I-shaped slimline body creates more space above and below the stage

The simple and slim I-shaped body has no projection on the body other than the focus knob, so there is more space in the working area for your experiment. This also provides better access around the microscope to position manipulators and other peripherals. With the eye-point of the body 25mm lower than conventional models, you can work in greater comfort.



Enhanced Noise Reduction and High Responsiveness to a Broad Range of Experimental Needs

■ Minimizing electronic noise

Nikon has succeeded in significantly reducing electrical noise by utilizing fiber illumination to bring light into the microscope from outside the cage. Noise can be dramatically reduced by connecting ground pins to all main parts of the microscope.

■ Ultimate vibration noise reduction

Nikon has achieved both improved rigidity and vibration resistance for the FN1 body by undertaking critical measurement and simulation analysis of its structure. Nikon has succeeded in suppressing the vibration generated when the nosepiece or the magnification module is switched.

■ Compatible with large specimens

The FN1 enables the microscope height to be raised by 10mm to 40mm by inserting up to four 10mm-thick spacers between the body and the arm. This is particularly advantageous for applications that require the observation of larger specimens such as intravital preps.



System Expansion

High-Resolution Confocal in-Vivo Imaging Systems

■ Multiphoton Confocal Microscope A1R MP+

With high speed multiphoton confocal imaging up to 420fps with the resonant scanner, A1R MP+ visualizes dynamics deep within living organisms. Unmixing of probes with overlapping spectra is also possible. The high-sensitivity Non-Descanned Detector and CFI Apo 25xW MP objective with superb transmission and aberration correction enable sharp, high-contrast imaging.



FN1-A1R MP+

■ Confocal Microscope C2+ series

C2+ series allows confocal patch-clamp imaging of deep areas of a specimen with excellent operability. Also, elimination of autofluorescence in vivo can be easily achieved.



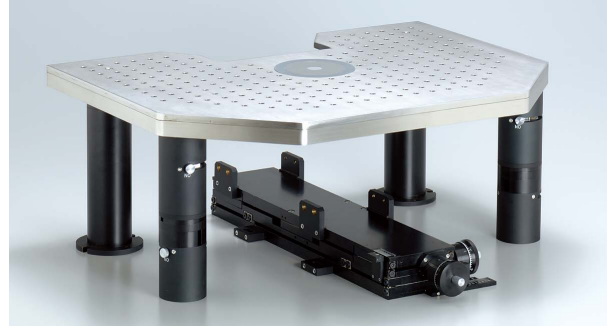
FN1-C2+

Accessories

Exclusive ITS-FN1 stage and mover

When Nikon and Narishige jointly developed the exclusive stage for the FN1, they placed priority on ease of use. The operator can easily sustain the stage in the horizontal position or switch the position of each pair of double magnet pillars and screwed pillars to suit individual experiments. With the microscope XY mover, it is possible to easily and precisely move to the region of interest by translating the whole microscope body in the X or Y axis direction.

Manufactured by Narishige Co., Ltd.



MT-1000 stage and mover

The pillars of this fixed stage, on which the manipulator and chamber are mounted, are designed as modular, making them compact and easy to customize. They can be freely placed around the mover, allowing effortless access to the microscope. By translating the microscope's optical system with the mover, observation and image acquisition of multiple specimen points are possible.

Manufactured by Sutter Instrument Company



Intensilight HG precentered fiber illuminator

The light source of this high-intensity 130W mercury illuminator for fluorescence observation can be placed away from the main equipment by liquid fiber connection, reducing influence of electric noise and heat exposure.



Mercury lamphouse for episcopic illumination

Episcopic illuminators

The NI-FLT6 Epi-Fluorescence Cube Turret accepts 6 filter cubes. Its built-in noise terminator cuts stray light to achieve an exceptionally high signal-to-noise ratio. The CI-FL Epi-Fluorescence Attachment accepts 4 filter cubes.



NI-FLT6 Epi-Fluorescence Cube Turret with NI-FLEI Epi-Fluorescence Attachment



CI-FL Epi-Fluorescence Attachment



LS-DWL-N diascope fiber-optics illuminator

Accepts a 12V-100W halogen lamp. Light intensity can be finely tuned via the light control knob or external controller, which can also turn the lamp on/off.

Manufactured by SUMITA Optical Glass, Inc.



Precentered lamphouse for diascope illumination

IR-DIC attachment

IR-DIC allows the visualization of minute structure deep within thick tissue of up to 300 or 400 μ m. Extremely high quality DIC images can be obtained using the IR polarizing set (850-950 nm) with a dedicated IR-CCD camera for image detection.



The IR-CCD camera in the photo is manufactured by Hamamatsu Photonics K. K.

Digital measuring unit (FN-MS Magnet Scale)

Accurate readout of the microscope body's Z axis moving distance at 1mm resolution is possible. The position of the manipulator can be adjusted with precision.



FN-MT magnification variable turret

Offers flexibility in changing intermediate magnifications between 1x, 1.25x, 1.5x and 2x without moving the objective lens. Vibration-free zooming can be achieved with every FN1 objective lens.



Sutter Instrument manipulators MPC-200+ROE-200

These electrophysiological manipulators realize stability and highly accurate and smooth operations.

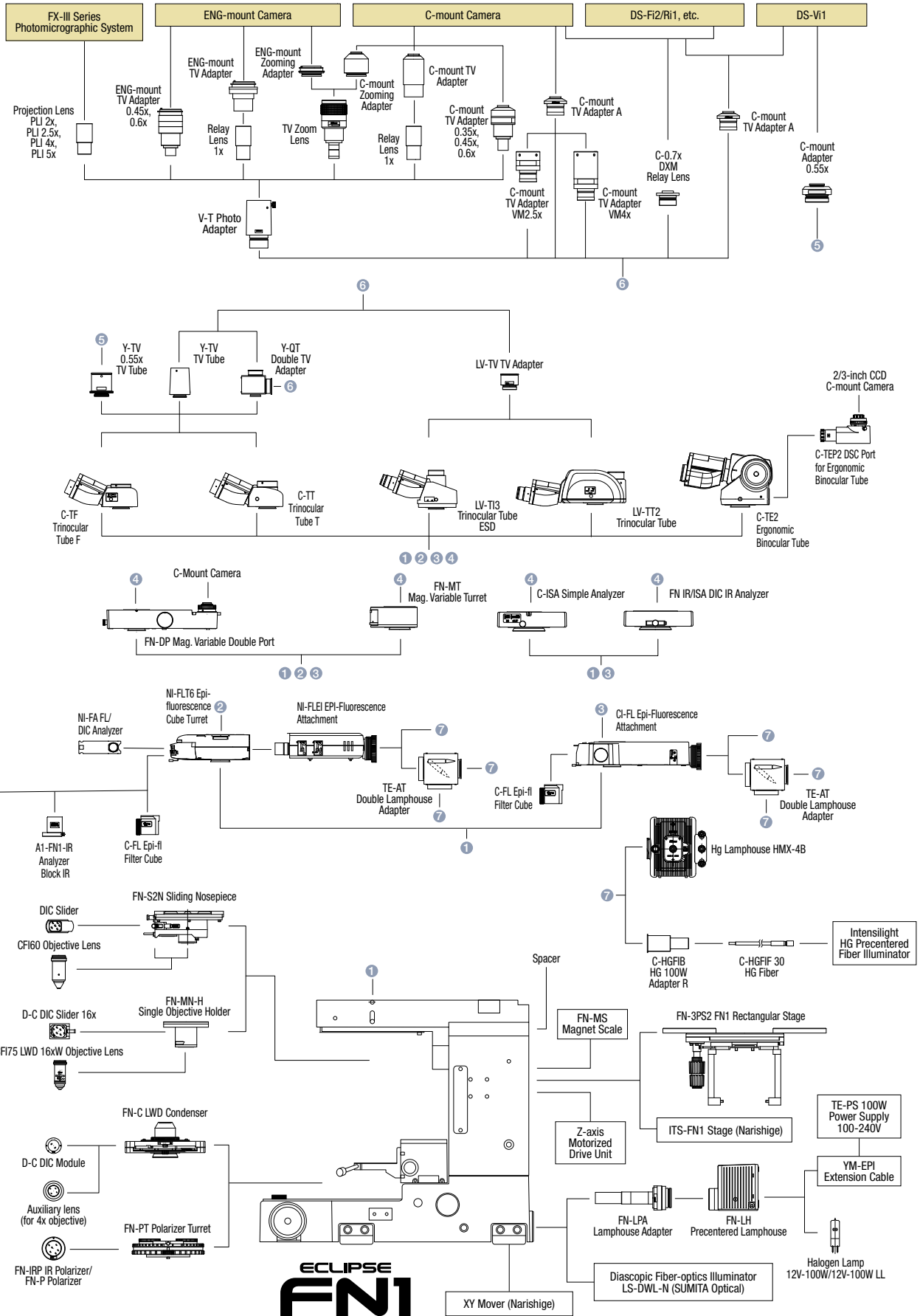


LV-TT2 Tilting Trinocular Eyepiece Tube

It delivers erect images as opposed to the inverted images seen through ordinary eyepiece tubes. Its height-adjustable design ensures a comfortable viewing posture even when an intermediate module is mounted.



System Diagram

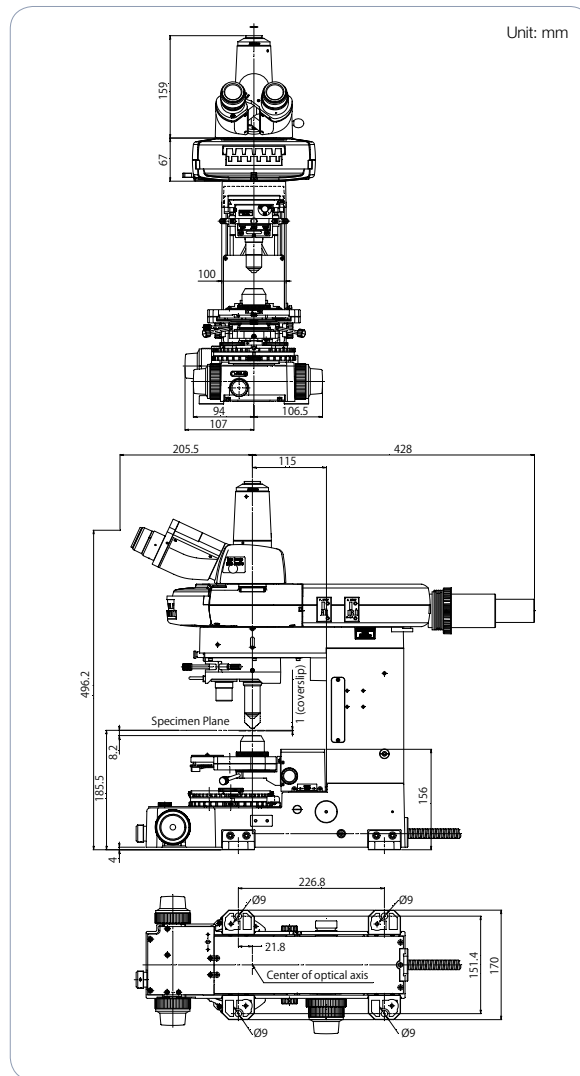


Specifications

Optical system	CFI60 and CFI75 infinity optical system
Main body	I-shaped, external power supply
Focusing	Via nosepiece up/down movement Manual coaxial coarse/fine focus knobs (on both sides)
Nosepiece	FN-S2N Sliding Nosepiece (for CFI60 objectives) Front/back 2-position; DIC prism attachable FN-MN-N Single Objective Holder (for CFI75 objective) 1-position; DIC prism attachable
Objectives	CFI Plan 4x NA: 0.10, W.D.: 30.0* CFI Plan Fluor 10xW NA: 0.30, W.D.: 3.5 CFI75 LWD 16xW NA: 0.80, W.D.: 3.0 CFI Apo 40xW NIR NA: 0.80, W.D.: 3.5 CFI Apo 60xW NIR NA: 1.00, W.D.: 2.8 CFI Plan 100xW NA: 1.10, W.D.: 2.5, with correction ring
LWD condenser	Universal turret type NA: 0.78, W.D.: 7.2mm DIC and Oblique Light observations possible
Eyepiece	10x, F.O.V.: 22
Eyepiece tubes	C-TE2 Ergonomic Binocular Tube (Bino 100%, Bino : DSC port = 50 : 50) (DSC port cannot be used with variable magnification double port) C-TF Trinocular Tube F (Bino : Photo = 100 : 0, 0 : 100) C-TT Trinocular Tube T (Bino : Photo = 100 : 0, 20 : 80, 0 : 100) LV-TI3 Trinocular Tube ESD (Bino : Photo = 100 : 0, 0 : 100) LV-TT2 Tilting Trinocular Tube (Bino : Photo = 100 : 0, 20 : 80, 0 : 100)
Stage	FN-3PS2 FN1 Rectangular Stage (3-plate mechanical stage) Stroke: 30mm (X, Y)
Light source	Intensilight HG Precentered Fiber Illuminator: 130W long-life mercury lamp Hg Lamphouse: 100W mercury lamp FN-LH Precentered Lamphouse: 12V-100W long-life halogen lamp LS-DWL-N Optical Fiber Illuminator (Sumita Optical Glass, Inc.): 12V-100W halogen lamp
Operating conditions	Temperature: +10°C to +40°C Humidity: 85%RH max. (no condensation)
Weight (main body)	Approx. 12kg

*1 Auxiliary lens is required.

Dimensional Diagram



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